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Application/Control No.	Applicant(s)/Patent under Reexamination	
10/810,659	YOO ET AL.	
Examiner	Art Unit	
Richard H. Kim	2871	

SEARCHED			
Class	Subclass	Date	Examiner
349	38	4/11/2007	RHK
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INTERFERENCE SEARCHED			
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SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
East Subclass Search (349/38)-jpo, uspat,pgpub,epo-see printout history	4/11/2007	RHK
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